Patent

Customer No. 31561 Application No.: 10/604,127

Docket No. 10221-US-PA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of

Applicant Application No. : Huang et al.

Filed

: 10/604,127 : June 27, 2003

For

: DRAINED WATER RECOVERY SYSTEM AND METHOD

FOR OPERATING THE SAME

Examiner

Art Unit

: 3753

INFORMATION DISCLOSURE STATEMENT

ASSISTANT COMISSIONER FOR PATENTS Arlington, VA22202

Enclosed is a PTO Form 1449 listing 3 reference(s), copy of which is attached. Applicant submits the reference(s) in compliance with his duty of disclosure pursuant to 37 CFR § 1.56 and 1.97. The Examiner is requested to make the citation(s) of official record.

This IDS is being submitted before the first Office Action. Thus, it is believed no fee is due.

The submission of the reference(s) should not be interpreted as admitting them as prior art.

Respectfully Submitted,

JIANQ CHYUN Intellectual Property Office

Date: March 1, 2004

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M PTO-1449 U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE STATEMENT BY
APPLICATION

ATTY. DOCKET NO.: 10221-US-PA APPLICATION NO.: 10/604,127					
APPLICANT: Huang et al.					
FILING DATE: June 27, 2003	GROUP 3753				

U.S. PATENT DOUCMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FIILNG DATE (IF APPROPRIATE)
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FOREIGN PATENT DOCUMENTS

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	FIILNG DATE (IF APPROPRIATE)
				 		
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EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)
	The Industrial Technology Research Institute and Powerchip Semiconductor Corp. are cooperating to face the challenge of the standard of over 90% wastewater-recycle rate; Water Conservation Quarterly Publication Volume 27
	Application of on-line TOC on Wastewater Treatment; Industrial Polution Control and Engineering Practice Technology Seminar Paper Anthology
	Ernest E. Ludwig; Applied Process Design for Chemical and Petrochemical Plants

EXAMINER	DATE CONSIDERED
BACALLA TITLE R	DATE CONSIDERED

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